Docket: 0756-2409

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THANK N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of

KOICHIRO TANAKA

Serial No. 10/021,719

Filed: 12/19/2001

For: LASER ANNEALING METHOD AND

SEMICONDUCTOR DEVICE

FABRICATING METHOD

Docket: 0756-2409

Croup Art Unit: 2881

Examiner: Unassigned

Docket: 0756-2409

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99

Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application.

Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

This *Information Disclosure Statement* is being issued before the issuance of a first Office Action and therefore no fee is required.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280. A duplicate copy of this sheet is attached.

Respectfully submitted,

Eric J. Robinson Reg. No. 38,285 Robinson Intellectual Property Law Office PMB 955, 21010 Southbank Street Potomac Falls, Virginia 20165 (571)434-6789 PERTERCATE OF MAIL INC

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				U.S. PATENT DOCUME	NTS		
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.